Author Index of Volume 54/55

Abbas, N. M., 1
Ajayi, O. O., 496
Alexander, W. B., 387
Allen, R., 343

Bancke, G. A., 19
Baouchi, A. W., 261
Barankova, H., 131
Bárdoš, L., 91
Barklund, A. M., 131
Barounig, J., 329
Bartsch, K., 193
Baumgärtner, M. E., 108
Beauprez, E., 115
Bendavid, A., 136
Berg, S., 91, 131
Bernard, C., 229
Bertram, R. W., 58
Beuger, J., 459
Biedroń, J., 84
Bodart, F., 279
Bogdanov, Ž., 502
Bolch, T., 599
Bordeaux, F., 70
Borom, M. P., 45
Bosserhoff, B., 102
Brennfleck, K., 13
Buchman, S., 548
Bull, S. J., 173
Burgmer, W., 249

Cameron, D. C., 355
Cappelli, M. A., 408
Chan, C., 343
Chang, C. S., 392
Chang, T. P., 490
Chatterjee, D., 516
Chen, C. -F., 368
Chen, J. L., 392
Chen, M. Y., 360
Cheng, H. S., 490
Chung, Y.-W., 360, 423
Clausing, R. E., 387
Cléry, M., 308
Collins, C. B., 581
Collins, G. A., 447
Cox, P., 224

Davanloo, F., 581
Davis, K., 548
Degout, D., 115
Delian, V., 96
Diot, C., 308
Doell, W., 167
Dravid, V. P., 360

Elstner, F., 338
Erdemir, A., 482, 496
Erkens, G., 541
Esser, S., 102

Fan, W. L., 380
Farges, G., 115, 266
Fenske, G. R., 496
Fessmann, J., 599
Fleischauer, P. D., 435
Flodström, A., 374
Formanek, B., 84
Franklin, S. E., 459
Freller, H., 148
Fritsch, R., 453
Fujita, T., 594
Funken, J., 541

Gageant, C., 308
Gale, W. F., 8
Gammel, F. J., 599
Garg, D., 198
Garscadden, A., 428
Geng, G. Q., 529
Ghosh, S., 516
Ghosh, S. K., 466
Giegengack, H., 338
Givens, J. H., 77
Godefroy, J. C., 308
Gouy-Pailler, Ph., 324
Graham, M. E., 490, 496
Gray, C., 548
Gredić, T., 502

Halvarsson, M., 186
Hantsche, H., 273
Hashimoto, M., 303
Hashmi, M. S. J., 355
Hatziandoniou, G., 447
Hayashi, Y., 365, 414
Heatherly, L., 387
Hecht, G., 338
Hendry, R. C., 397
Herman, H., 19
Hettiarachchi, S., 224
Hibino, Y., 365, 414
Hilton, M. R., 435
Hochman, R. F., 315
Hofmann, D., 586
Höhl, F., 160
Hollars, D., 552
Holloway, P. H., 387
Hong, K. T., 64
Hong, T. -M., 368
Hsieh, J. H., 315
Hsu, L., 39
Huang, T. H., 392
Hudson, G. C., 397
Huettner, W., 13
Hur, S. K., 64
Hutchings, R., 447

Imai, H., 143

Jackson, H. E., 576
Jamarani, F., 58
Jankowski, A. F., 349
Jehn, H. A., 108, 273
Johnson, C. A., 45
Jones, A. M., 173
Jonke, D., 599

Kadlec, S., 287
Kammermeier, D., 470
Kampschulte, G., 599
Kanetkar, S. M., 508
Karim, M. Z., 355
Kassner, R., 167
Katardjiev, I. V., 131
Kawata, K., 604
Kayser, P., 308
Kelly, C. M., 198
Khan, J., 590
Kim, C., 335
Kinder, T. J., 136
King, J. E., 8
Kiyota, F., 594
Kleer, G., 167
Knotek, O., 102, 241, 249, 476, 536
Kobayashi, T., 418
Kohler, M. S., 466
Komuro, T., 594
König, W., 453, 470
Kopacz, U., 273
Korotkin, M., 58
Koskinen, J., 570
Krämer, G., 241, 476
Kreutz, E. W., 541
Kubo, H., 255
Kulkarni, A. V., 508
Kuo, C. T., 392
Kupfer, H., 338
Kuznetsov, G., 96

Lang, R. V., 58
Lau, K., 219
Lau, K. H, 224, 234
Lee, H. J., 552
Lee, J. D., 64
Lee, J. K., 552
Lee, T. J., 581
Lemmer, O., 102, 541
Leonhardt, A., 193
Levy, A. V., 529
Leyendecker, F., 599
Leyendecker, T., 102
Likonen, J., 570
Lin, T. S., 392
Lin, X., 360
Liss, K. -D., 229
Löffler, F., 241, 476, 536
Loh, M. H., 408
Lorenz, H. -P., 148
Losbichler, P., 329

Maciejny, A., 84
Madar, R., 229
Magerl, A., 229
Majumdar, D., 516
Mann, D., 599
Maréchal, N., 320
Markunas, R. J., 397
Martin, P. J., 136
Mastromatteo, E., 229
Mate, N., 508
Maury, F., 204
Mayr, P., 160
McCabe, A. R., 173
Meassick, S., 343
Mertz, K., 599
Metwally, M., 25
Meyer, E. -M., 167
Meyer, M., 599
Mitterer, C., 329
Miyake, S., 563
Miyoshi, K., 428, 576
Moon, D., 335
Moreau, C., 70
Murakawa, M., 403
Musil, J., 287
Mutasim, Z., 39

Nender, C., 131
Netterfield, R. P., 136
Nichols, F. A., 496

Ogale, S. B., 508
Ogawa, M., 418
Oral, B., 374
Ossola, F., 204
Ouellette, M. F., 58

Page, T. F., 557
Païdassi, S., 320, 324
Pan, F. M., 392
Parameswaran, V. R., 58
Park, H., 581
Pauleau, Y., 320, 324
Pauza, A., 447
Perry, A. J., 180, 261
Petersen, J. H., 261
Popović, N., 502
Posthill, J. B., 397
Pozder, S. D., 261
Prasad, S. V., 442

Qadri, S. B., 335
Quaeyhaegens, C., 121, 279

Ra, H. Y., 64
Rack, A., 273

Rafaja, D., 180
Reid, J. V., 521
Reiners, G., 273
Rhys-Jones, T. N., 1
Richter, F., 338
Riggs II, W. L., 19
Rigsbee, J. M., 77
Rokkaku, T., 418
Ronkainen, H., 570
Rudder, R. A., 397
Rudnik, P. J., 496

Saint Jacques, R. G., 70
Sainte-Catherine, M. C., 266
Samandi, M., 447
Sanjurjo, A., 219, 224, 234
Sartwell, B. D., 180
Schaarschmidt, G., 338
Schack, P., 148
Scheiffarth, J. H., 13
Schinker, M. G., 167
Scholze, F., 338
Schrawyer, L. R., 349
Schrey, A., 102
Schuster, F., 204
Shanov, V., 25
Sheward, J. A., 297
Shih, H. C., 380
Shiotani, S., 586
Shirai, M., 143
Skogsmo, J., 186
Smallen, M., 552
Sproul, W. D., 360, 490, 496
Stals, L. M. M., 121, 279
Stavros, A. J., 521
Stock, H. -R., 160
Stoessel, C., 249
Stōri, H., 329
Suchentrunk, R., 599
Sue, J. A., 154
Sueyoshi, Y., 143
Sung, C. P., 380
Sung, H., 541
Swadźba, L., 84

Tabakoff, W., 25
Takeuchi, S., 403
Tamagaki, H., 594
Tamura, M., 255
Tawancy, H. M., 1
Taylor, T. A., 53
Tendys, J., 447
Terwagne, G., 279
Thomas, R. E., 397
Tiller, W. A., 211
Tokumaru, S., 303
Tominaga, K., 143
Tsuji, K., 594
Tsukamoto, H., 418
Tucker, Jr., R. C., 32
Turneaure, J. P., 548
Twigg, M., 335

Valvoda, V., 180
Van Stappen, M., 121, 279
Varacalle, Jr., D. J., 19
Vlaeminck, R., 279
Voss, A., 541
Vuorinen, S., 186
Vuppuladhadium, R., 576
Vyskočil, J., 287
Wada, T., 418
Wagh, B. G., 508
Wagner, B. J., 13
Walsh, P. N., 32
Wang, B. Q., 529
Weitkamp, K., 536
Werner, W. S. M., 329
Williamson, D. L., 180
Wolf, E., 193
Wong, E., 39
Wong, M. S., 360
Wood, B., 219, 224
Wood, B. J., 234
Wright, T., 557
Wu, R. L. C., 428, 576

Yamashita, N., 418
Yan, K. L., 58
Yasbandha, H., 447
You, J. H., 581

Zhou, P., 548
Zlatanović, M., 502
Zubeck, R., 552

Subject Index of Volume 54/55

Abradable coatings
evaluation of plasma sprayed abradable coatings, 39
Abrasion
study of the relative wear and abrasion resistance of Ti(C,N) and TiN coatings, 466
Acoustic emission
acoustic emission study of failure mechanisms in TiC thermal barrier coatings, 70
Adhesion
adhesion and structure of c-BN films produced by ion-beam-assisted deposition, 418
Alumina
high resistivity AlO_x thin films deposited by a novel two-step sputtering process, 303
microstructural study of the κ-$Al_2O_3 \rightarrow \alpha$-$Al_2O_3$ transformation in CVD κ-Al_2O_3, 186
vacuum plasma sprayed alumina–titania coatings, 19
Aluminium
Al and alumina coatings on Cu by CVD in fluidized bed reactors, 234
Al metal matrix composites tailored for antifriction applications, 442
ion-beam deposition of Zr–Al multilayers and their structural properties, 335
some tribological observations of sliding W carbide coated steel against Al, 521
morphology and mechanical properties of Al_2O_3, ZrO_2 and SiC laser-assisted physically vapour-deposited films, 541
Aluminium matrix composites
TiN films as microlaminate reinforcements in Al matrix composites, 77
Aluminium nitride
effect of process parameters on the residual stresses and the wear behavior of Al nitride physical vapor deposition coatings, 167
Amorphic diamond
protective coatings of amorphic diamond on fragile and sensitive substrates, 581
Anodic vacuum arc
thin film deposition techniques utilizing the anodic vacuum arc, 343
Arc deposition
thin film deposition techniques utilizing the anodic vacuum arc, 343
Arc evaporation
arc-evaporated Ti–V–N thin films, 249
crystal structure of Mo nitride films made by reactive cathodic arc evaporation, 261
the deposition of thin films by filtered arc evaporation, 136
Ti–B–N coatings deposited by magnetron arc evaporation, 255
Arc ion plating
in-line arc-ion plating system for high throughput processing of automobile parts, 594
Arcjets
diamond synthesis in supersonic direct-current arcjet plasma at subtorr pressures, 408
Auger electron spectroscopy
interface study of physically vapour-deposited TiN coatings on plasma-nitrided tool steel surfaces with Auger electron spectroscopy, resonant nuclear reaction analysis and Rutherford backscattering spectroscopy, 279
Automobile parts
in-line arc-ion plating system for high throughput processing of automobile parts, 594

Boron
sputter deposition of decorative coatings based on ZrB_2 and ZrB_{12}, 329
Ti–B–N coatings deposited by magnetron arc evaporation, 255
Boron nitride
adhesion and structure of c-BN films produced by ion-beam-assisted deposition, 418
effect of deposition parameters on the formation of cubic BN films deposited by plasma-assisted CVD from non-toxic material, 355

Carbides
diamond film growth on cemented W carbides studied by scanning electron microscopy, Auger electron spectroscopy and X-ray photoelectron spectroscopy, 392
performance and wear of carbide coated by physical vapour deposition in interrupted cutting, 453
some tribological observations of sliding W carbide coated steel against Al, 521
study of the relative wear and abrasion resistance of Ti(C,N) and TiN coatings, 466
Carbon
growth and characterization of C–N thin films, 360
increasing high temperature oxidation and corrosion resistance of graphite and carbon-fiber-reinforced carbon by deposition of a low pressure chemically vapor-deposited silicon carbide coating, 13
Carbon dioxide
the role of H in diamond synthesis from carbon dioxide-hydrocarbon gases by microwave plasma CVD, 368
Carbon fibre
adherent metallization of carbon-fibre-reinforced plastic composites using a combined vacuum/electrochemical deposition process, 599
Catalysis
synthesis of diamond thin films through a transformation of a catalytically produced diamond precursor phase, 374
Ceramics
erosive wear of CVD ceramic coatings exposed to particulate flow, 25
Characterization
growth and characterization of C–N thin films, 360
preparation and characterization of V–N films deposited by reactive triode magnetron sputtering, 115
TiN films as microlaminate reinforcements in Al matrix composites, 77
Chromium
assessment of tetra-alkylchromium compounds for low temperature organo-metallic CVD of Cr-based coatings, 204
impurities in ion plated Cr films, 315
sputtered silver and Cr–C films for applications as interconnect materials, 320
Coated cemented carbides
substrate- and interface-related influences on the performance of arc-physical-vapour-deposition-coated cemented carbides in interrupted-cut machining, 476

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Coating impact test
a new technique for testing the impact load of thin films, 102
Combined processes
adherent metallization of carbon-fibre-reinforced plastic composites using a combined vacuum/electrochemical deposition process, 599
Composites
adherent metallization of carbon-fibre-reinforced plastic composites using a combined vacuum/electrochemical deposition process, 599
Al metal matrix composites tailored for antifriction applications, 442
Composition
decorative properties and chemical composition of hard coatings, 273
deposition of ternary hard compounds with a graded composition by the use of a hybrid source ion-plating technique, 148
working gas pressure and flow effects on reactively sputtered Mo oxide thin films, 349
Copper
Al and alumina coatings on Cu by CVD in fluidized bed reactors, 234
multilayer Ti–Cu sputter films for the Gravity Probe B gyroscope housings, 548
Corrosion
coatings for corrosion protection of steel used in reinforced concrete, 224
corrosion studies with hard coating–substrate systems, 108
erosion and erosion-corrosion behavior of chromized-siliconized steel, 529
increasing high temperature oxidation and corrosion resistance of graphite and carbon-fibre-reinforced carbon by deposition of a low pressure chemically vapor-deposited silicon carbide coating, 13
Cracking resistance
microstructure and resistance to cracking of modified Al–Si and Al–Cr diffusion coatings on ŻS6K nickel-based superalloys, 84
Crystallites
crystallite geometry of hot filament chemical vapor deposited diamond, 387
Cutting
performance and wear of carbide coated by physical vapour deposition in interrupted cutting, 453
Cutting tools
multicomponent and multilayer physically vapour deposited coatings for cutting tools, 241

Decoration
decorative properties and chemical composition of hard coatings, 273
sputter deposition of decorative coatings based on ZrB_2 and ZrB_{12}, 329
Dental prostheses
physical vapour deposition coatings for dental prostheses, 536
Deposition parameters
effect of deposition parameters on the formation of cubic BN films deposited by plasma-assisted CVD from non-toxic material, 355
Diamond
crystallite geometry of hot filament chemical vapor deposited diamond, 387
diamond coating using multiple flame torches in an atmospheric chamber, 403
diamond film growth on cemented W carbides studied by scanning electron microscopy, Auger electron spectroscopy and X-ray photoelectron spectroscopy, 392
diamond synthesis in supersonic direct-current arcjet plasma at subtorr pressures, 408
effects of noble gases on the formation of CVD diamond film, 380
formation of diamond films from low pressure radio frequency induction discharges, 397
friction and wear of diamond and diamondlike carbon coatings, 428
increase in nucleation density in diamond film growth by d.c. plasma CVD, 365
investigation of the early stages of diamond film growth by ellipsometric monitoring, 414
protective coatings of amorphic diamond on fragile and sensitive substrates, 581
synthesis of diamond thin films through a transformation of a catalytically produced diamond precursor phase, 374
the role of H in diamond synthesis from C dioxide-hydrocarbon gases by microwave plasma CVD, 368
Diamond-like carbon
friction and wear of diamond and diamondlike carbon coatings, 428
physical and tribological properties of rapid thermal annealed diamond-like C films, 576
tribological properties of hard carbon films produced by the pulsed vacuum arc discharge method, 570
Dies
development of mass-production-type plasma CVD equipment and its application to various dies, 604
Diffraction
low pressure CVD of massive $Si_{1-x}Ge_x$ gradient crystals and applications in short-wavelength diffraction, 229
Diffusion coatings
microstructural development in aluminide diffusion coatings on nickel-base superalloy single crystals, 8
microstructure and resistance to cracking of modified Al–Si and Al–Cr diffusion coatings on ŻS6K nickel-based superalloys, 84

Ellipsometric monitoring
investigation of the early stages of diamond film growth by ellipsometric monitoring, 414
Environment
effects of surface composition, environment and morphology on friction and wear, 423
Erodent characteristics
influence of erodent characteristics on the erosion of selected coatings at ambient and elevated temperature, 32
Erosion
erosion and erosion-corrosion behavior of chromized-siliconized steel, 529
erosive wear of CVD ceramic coatings exposed to particulate flow, 25
influence of erodent characteristics on the erosion of selected coatings at ambient and elevated temperature, 32
sputter erosion amplification, 131
Etching
the use of ion effects on the surface in deposition and etching of thin films and coatings, 96

Failure mechanisms
acoustic emission study of failure mechanisms in TiC thermal barrier coatings, 70
Fatigue
rolling-contact fatigue and wear resistance of hard coatings on bearing-steel substrates, 482
Film growth
diamond film growth on cemented W carbides studied by scanning

electron microscopy, Auger electron spectroscopy and X-ray photoelectron spectroscopy, 392
growth and characterization of C–N thin films, 360
increase in nucleation density in diamond film growth by d.c. plasma CVD, 365
investigation of the early stages of diamond film growth by ellipsometric monitoring, 414
Flame torches
diamond coating using multiple flame torches in an atmospheric chamber, 403
Flow effects
working gas pressure and flow effects on reactively sputtered Mo oxide thin films, 349
Fluidized bed reactors
Al and alumina coatings on Cu by CVD in fluidized bed reactors, 234
CVD in fluidized bed reactors, 219
Friction
Al metal matrix composites tailored for antifriction applications, 442
effects of surface composition, environment and morphology on friction and wear, 423
friction and wear of diamond and diamondlike carbon coatings, 428
tribological properties of hard C films: extremely low friction mechanism of amorphous hydrogenated C films and amorphous hydrogenated SiC films in vacuum, 563
Fundamental mechanisms
fundamental mechanisms of Ti nitride formation by d.c. magnetron sputtering, 338

Gas pressure
working gas pressure and flow effects on reactively sputtered Mo oxide thin films, 349
Germanium
low pressure CVD of massive $Si_{1-x}Ge_x$ gradient crystals and applications in short-wavelength diffraction, 229
Gradient crystals
low pressure CVD of massive $Si_{1-x}Ge_x$ gradient crystals and applications in short-wavelength diffraction, 229
Graphite
increasing high temperature oxidation and corrosion resistance of graphite and carbon-fiber-reinforced carbon by deposition of a low pressure chemically vapor-deposited silicon carbide coating, 13
Gravity Probe B
multilayer Ti–Cu sputter films for the Gravity Probe B gyroscope housings, 548
Growth
fundamental aspects of film nucleation and growth in CVD, 211
growth and properties of hard coatings prepared by physical vapor deposition methods, 287
Gyroscope housings
multilayer Ti–Cu sputter films for the Gravity Probe B gyroscope housings, 548

Hard carbon
nanoindentation and microindentation studies of hard carbon on 304 stainless steel, 557
tribological properties of hard C films; extremely low friction mechanism of amorphous hydrogenated C films and amorphous hydrogenated SiC films in vacuum, 563
Hard coatings
corrosion studies with hard coating–substrate systems, 108
decorative properties and chemical composition of hard coatings, 273
deposition of multilayer hard coatings using kinetically controlled CVD processes, 193
growth and properties of hard coatings prepared by physical vapor deposition methods, 287
structure and mechanical properties of hard W–C coatings deposited by reactive magnetron sputtering, 324
Heat fluxmeters
sputtered yttria partially stabilized zirconia layers applied to thin film heat fluxmeters, 308
Heat transfer
CVD in fluidized bed reactors, 219
Highly ionized plasmas
recent progress in the study of physically vapour-deposited coatings produced by means of highly ionized plasmas, 121
Hot filaments
crystallite geometry of hot filament chemical vapor deposited diamond, 387
Hydrogen
the role of hydrogen in diamond synthesis from C dioxide-hydrocarbon gases by microwave plasma CVD, 368
Hydrogenated carbon
properties of sputter-deposited hydrogenated C films as a tribological overcoat used in rigid magnetic disks, 552
tribological properties of hard C films: extremely low friction mechanism of amorphous hydrogenated C films and amorphous hydrogenated SiC films in vacuum, 563

Impact load
a new technique for testing the impact load of thin films, 102
Implantation
on the residual stress and picostructure of Ti nitride films I: Implantation with argon or krypton, 180
Impurities
impurities in ion plated Cr films, 315
Industrial equipment
development of mass-production-type plasma CVD equipment and its application to various dies, 604
Industrial methods
industrial sputter coating of large stainless steel sheets, 586
Interconnect materials
sputtered silver and Cr–C films for applications as interconnect materials, 320
Interfaces
interface study of physically vapour-deposited TiN coatings on plasma-nitrided tool steel surfaces with Auger electron spectroscopy, resonant nuclear reaction analysis and Rutherford backscattering spectroscopy, 279
Internal surfaces
the coating of internal surfaces by PVD techniques, 297
Interrupted-cut machining
substrate- and interface-related influences on the performance of arc-physical-vapour-deposition-coated cemented carbides in interrupted-cut machining, 476
Ion beams
adhesion and structure of c-BN films produced by ion-beam-assisted deposition, 418
ion-beam deposition of Zr–Al multilayers and their structural properties, 335
residual stress in ion-assisted coatings, 173
Ion effects
the use of ion effects on the surface in deposition and etching of thin films and coatings, 96
Ion implantation
effects of N ion implantation on the mechanical properties of laser-deposited thin films of TiC and TiN on stainless steel, 508

Ion plating
impurities in ion plated Cr films, 315
Ion-plating techniques
deposition of ternary hard compounds with a graded composition by the use of a hybrid source ion-plating technique, 148

Kinetic control
deposition of multilayer hard coatings using kinetically controlled CVD processes, 193

Lubrication
applications of solid lubricant films in spacecraft, 435
tribological behavior of oil-lubricated TiN-coated steel, 496

Machining
substrate- and interface-related influences on the performance of arc-physical-vapour-deposition-coated cemented carbides in interrupted-cut machining, 476
Macroparticle filtering
deposition of thin films by filtered arc evaporation, 136
Magnetic disks
properties of sputter-deposited hydrogenated C film as a tribological overcoat used in rigid magnetic disks, 552
Magnetron arc evaporation
Ti–B–N coatings deposited by magnetron arc evaporation, 255
Magnetron sputtering
fundamental mechanisms of Ti nitride formation by d.c. magnetron sputtering, 338
microstructural and tribological study of triode magnetron sputtered V–C coatings: influence of partial pressure of reactive gas, 266
planar magnetron-sputtering system with obliquely facing targets, 143
preparation and characterization of V–N films deposited by reactive triode magnetron sputtering, 115
Martensitic transformation
the effect of residual stress on martensitic transformation in plasma-sprayed ZrO_2 (8wt.% Y_2O_3) coatings, 64
Mass transfer
CVD in fluidized bed reactors, 219
Mechanical properties
effects of N ion implantation on the mechanical properties of laser-deposited thin films of TiC and TiN on stainless steel, 508
examination of residual stress, morphology and mechanical properties of sputtered TiN films, 160
morphology and mechanical properties of Al_2O_3, ZrO_2 and SiC laser-assisted physically vapour-deposited films, 541
structure and mechanical properties of hard W–C coatings deposited by reactive magnetron sputtering, 324
Metallization
adherent metallization of carbon-fibre-reinforced plastic composites using a combined vacuum/electrochemical deposition process, 599
Microindentation
nanoindentation and microindentation studies of hard carbon on 304 stainless steel, 557
Microlaminate reinforcements
TiN films as microlaminate reinforcements in Al matrix composites, 77
Microstructure
microstructural and tribological study of triode magnetron sputtered V–C coatings: influence of partial pressure of reactive gas, 266
microstructural development in aluminide diffusion coatings on nickel-base superalloy single crystals, 8
microstructural study of the κ-$Al_2O_3 \rightarrow \alpha$-$Al_2O_3$ transformation in CVD κ-Al_2O_3, 186
microstructure and resistance to cracking of modified Al–Si and Al–Cr diffusion coatings on ŻS6K nickel-based superalloys, 84
microstructure and tribological behaviour of plasma immersion ion implanted tool steels, 447
thermal properties and microstructure of two thermal barrier coatings, 53
Microwave plasma techniques
the role of H in diamond synthesis from C dioxide-hydrocarbon gases by microwave plasma CVD, 368
Molybdenum nitride
crystal structure of Mo nitride films made by reactive cathodic arc evaporation, 261
Molybdenum oxide
working gas pressure and flow effects on reactively sputtered Mo oxide thin films, 349
Mononitrides
arc-evaporated Ti–V–N thin films, 249
Morphology
effects of surface composition, environment and morphology on friction and wear, 423
examination of residual stress, morphology and mechanical properties of sputtered TiN films, 160
the morphology and mechanical properties of Al_2O_3, ZrO_2 and SiC laser-assisted physically vapour-deposited films, 541
Multilayers
deposition of multilayer hard coatings using kinetically controlled CVD processes, 193
ion-beam deposition of Zr–Al multilayers and their structural properties, 335
multicomponent and multilayer physically vapour deposited coatings for cutting tools, 241

Nanoindentation
nanoindentation and microindentation studies of hard carbon on 304 stainless steel, 557
Nitrides
study of the relative wear and abrasion resistance ot Ti(C,N) and TiN coatings, 466
Nitriding
properties of TiN coatings deposited onto hot work steel substrates plasma nitrided at low pressure, 502
Nitrogen
growth and characterization of C–N thin films, 360
Noble gases
effects of noble gases on the formation of CVD diamond films, 380
Non-toxic material
effect of deposition parameters on the formation of cubic BN films deposited by plasma-assisted CVD from non-toxic material, 355
Novel process
high resistivity AlO_x thin films deposited by a novel two-step sputtering process, 303
Nuclear reaction analysis
interface study of physically vapour-deposited TiN coatings on plasma-nitrided tool steel surfaces with Auger electron spectroscopy, resonant nuclear reaction analysis and Rutherford backscattering spectroscopy, 279
Nucleation
fundamental aspects of film nucleation and growth in CVD, 211
Nucleation density
increase in nucleation density in diamond film growth by d.c. plasma CVD, 365

Oblique targets
planar magnetron-sputtering system with obliquely facing targets, 143
Organo-metallic CVD
assessment of tetra-alkylchromium compounds for low temperature organo-metallic CVD of Cr-based coatings, 204
Oxidation
effect of substrate composition on the oxidation behavior of Pt-aluminized nickel-base superalloys, 1
increasing high temperature oxidation and corrosion resistance of graphite and carbon-fiber-reinforced carbon by deposition of a low pressure chemically vapor-deposited silicon carbide coating, 13

Partial pressure
microstructural and tribological study of triode magnetron sputtered V–C coatings: influence of partial pressure of reactive gas, 266
Particulate flow
erosion wear of CVD ceramic coatings exposed to particulate flow, 25
Performance
performance and wear of carbide coated by physical vapour deposition in interrupted cutting, 453
Phase relationships
thermomechanical behavior and phase relationships of plasma-sprayed zirconia coatings, 45
Phase transformation
microstructural study of the κ-$Al_2O_3 \rightarrow \alpha$-$Al_2O_3$ transformation in CVD κ-Al_2O_3, 186
synthesis of diamond thin films through a transformation of a catalytically produced diamond precursor phase, 374
Physical properties
physical and tribological properties of rapid thermal annealed diamond-like carbon films, 576
Physical vapour deposition
growth and properties of hard coatings prepared by physical vapor deposition methods, 287
new ways towards better exploitation of physical vapour deposition coatings, 470
physical vapour deposition coatings for dental prostheses, 536
Picostructure
on the residual stress and picostructure of Ti nitride films I: Implantation with argon or krypton, 180
Plasma methods
development of mass-production-type plasma CVD equipment and its application to various dies, 604
effect of deposition parameters on the formation of cubic BN films deposited by plasma-assisted CVD from non-toxic material, 355
increase in nucleation density in diamond film growth by d.c. plasma CVD, 365
Plasma spraying
effect of residual stress on martensitic transformation in plasma-sprayed ZrO_2 (8wt.% Y_2O_3) coatings, 64
evaluation of plasma sprayed abradable coatings, 39
thermomechanical behavior and phase relationships of plasma-sprayed zirconia coatings, 45
Plasma techniques
low pressure r.f. plasma jet—a new tool for surface processing, 91
microstructure and tribological behaviour of plasma immersion ion implanted tool steels, 447
recent progress in the study of physically vapour-deposited coatings produced by means of highly ionized plasmas, 121
Plastics
adherent metallization of carbon-fibre-reinforced plastic composites using a combined vacuum/electrochemical deposition process, 599
Preparation
preparation and characterization of V–N films deposited by reactive triode magnetron sputtering, 115
Process parameters
effect of process parameters on the residual stresses and the wear behavior of Al nitride physical vapor deposition coatings, 167
Properties
new ways towards better exploitation of physical vapour deposition coatings, 470
Protective coatings
protective coatings of amorphic diamond on fragile and sensitive substrates, 581

Radio frequency induction
formation of diamond films from low pressure radio frequency induction discharges, 397
Rapid thermal annealing
physical and tribological properties of rapid thermal annealed diamond-like C films, 576
Reactive gases
microstructural and tribological study of triode magnetron sputtered V–C coatings: influence of partial pressure of reactive gas, 266
Reactor design
reactor design for CVD of W carbide coatings, 198
Reinforced concrete
coatings for corrosion protection of steel used in reinforced concrete, 224
Residual stress
effect of process parameters on the residual stresses and the wear behavior of Al nitride physical vapor deposition coatings, 167
effect of residual stress on martensitic transformation in plasma-sprayed ZrO_2 (8wt.% Y_2O_3) coatings, 64
examination of residual stress, morphology and mechanical properties of sputtered TiN films, 160
on the residual stress and picostructure of Ti nitride films I: Implantation with argon or krypton, 180
residual stress in ion-assisted coatings, 173
X-ray elastic constants and residual stress of textured Ti nitride coating, 154
Rolling
scuffing behavior of TiN-coated steel rollers under rolling and sliding conditions, 490
Rolling-contact fatigue
rolling-contact fatigue and wear resistance of hard coatings on bearing-steel substrates, 482
Rutherford backscattering spectroscopy
interface study of physically vapour-deposited TiN coatings on plasma-nitrided tool steel surfaces with Auger electron spectroscopy, resonant nuclear reaction analysis and Rutherford backscattering spectroscopy, 279

Scuffing behavior
scuffing behavior of TiN-coated steel rollers under rolling and sliding conditions, 490
Silicon
low pressure CVD of massive $Si_{1-x}Ge_x$ gradient crystals and applications in short-wavelength diffraction, 229
Silicon carbide
increasing high temperature oxidation and corrosion resistance of graphite and carbon-fiber-reinforced C by deposition of a low pressure chemically vapor-deposited Si carbide coating, 13
the morphology and mechanical properties of Al_2O_3, ZrO_2 and SiC laser-assisted physically vapour-deposited films, 541

tribological properties of hard C films: extremely low friction mechanism of amorphous hydrogenated C films and amorphous hydrogenated SiC films in vacuum, 563
Sliding
scuffing behavior of TiN-coated steel rollers under rolling and sliding conditions, 490
Spacecraft
applications of solid lubricant films in spacecraft, 435
Sputtering
examination of residual stress, morphology and mechanical properties of sputtered TiN films, 160
high resistivity AlO_x thin films deposited by a novel two-step sputtering process, 303
industrial sputter coating of large stainless steel sheets, 586
properties of sputter-deposited hydrogenated C films as a tribological overcoat used in rigid magnetic disks, 552
sputtering deposition of decorative coatings based on ZrB_2 and ZrB_{12}, 329
sputter erosion amplification, 131
sputtered silver and Cr–C films for applications as interconnect materials, 320
sputtered yttria partially stabilized zirconia layers applied to thin film heat fluxmeters, 308
structure and mechanical properties of hard W–C coatings deposited by reactive magnetron sputtering, 324
working gas pressure and flow effects on reactively sputtered Mo oxide thin films, 349
Stainless steel
effects of N ion implantation on the mechanical properties of laser-deposited thin films of TiC and TiN on stainless steel, 508
industrial sputter coating of large stainless steel sheets, 586
nanoindentation and microindentation studies of hard C on 304 stainless steel, 557
Steel
coatings for corrosion protection of steel used in reinforced concrete, 224
effects of N ion implantation on the mechanical properties of laser-deposited thin films of TiC and TiN on stainless steel, 508
erosion and erosion–corrosion behavior of chromized-siliconized steel, 529
industrial sputter coating of large stainless steel sheets, 586
microstructure and tribological behaviour of plasma immersion ion implanted tool steels, 447
properties of TiN coatings deposited onto hot work steel substrates plasma nitrided at low pressure, 502
rolling-contact fatigue and wear resistance of hard coatings on bearing-steel substrates, 482
scuffing behavior of TiN-coated steel rollers under rolling and sliding conditions, 490
some tribological observations of sliding W carbide coated steel against Al, 521
tribological behavior of oil-lubricated TiN-coated steel, 496
Steel tubes
the coating of internal surfaces by PVD techniques, 297
Structure
adhesion and structure of c-BN films produced by ion-beam-assisted deposition, 418
crystal structure of Mo nitride films made by reactive cathodic arc evaporation, 261
ion-beam deposition of Zr–Al multilayers and their structural properties, 335
structure and mechanical properties of hard W–C coatings deposited by reactive magnetron sputtering, 324
Substrate composition
effect of substrate composition on the oxidation behavior of Pt-aluminized nickel-base superalloys, 1
Superalloys
effect of substrate composition on the oxidation behavior of Pt-aluminized nickel-base superalloys, 1
microstructural development in aluminide diffusion coatings on nickel-base superalloy single crystals, 8
microstructure and resistance to cracking of modified Al–Si and Al–Cr diffusion coatings on ŻS6k nickel-based superalloys, 84
Surface composition
effects of surface composition, environment and morphology on friction and wear, 423
Surface modification
surface modification and wear characteristics of yttria-doped zirconia, 516
Surface processing
low pressure r.f. plasma jet—a new tool for surface processing, 91
Surfaces
The use of ion effects on the surface in deposition and etching of thin films and coatings, 96
Synthesis
synthesis of diamond thin films through a transformation of a catalytically produced diamond precursor phase, 374

Ternary hard compounds
deposition of ternary hard compounds with a graded composition by the use of a hybrid source ion-plating technique, 148
Tetra-alkylchromium compounds
assessment of tetra-alkylchromium compounds for low temperature organo-metallic CVD of Cr-based coatings, 204
Thermal barrier coatings
acoustic emission study of failure mechanisms in TiC thermal barrier coatings, 70
compositionally graded thermal barrier coatings for high temperature aero gas turbine components, 58
thermal properties and microstructure of two thermal barrier coatings, 53
Thermomechanical behavior
thermomechanical behavior and phase relationships of plasma-sprayed zirconia coatings, 45
Titania
vacuum plasma sprayed alumina-titania coatings, 19
Titanium
arc-evaporated Ti–V–N thin films, 249
multilayer Ti–Cu sputter films for the Gravity Probe B gyroscope housings, 548
study of the relative wear and abrasion resistance of Ti(C,N) and TiN coatings, 466
Ti–B–N coatings deposited by magnetron arc evaporation, 255
Titanium carbide
acoustic emission study of failure mechanisms in TiC thermal barrier coatings, 70
effects of N ion implantation on the mechanical properties of laser-deposited thin films of TiC and TiN on stainless steel, 508
Titanium nitride
effects of N ion implantation on the mechanical properties of laser-deposited thin films of TiC and TiN on stainless steel, 508
examination of residual stress, morphology and mechanical properties of sputtered TiN films, 160
fundamental mechanisms of Ti nitride formation by d.c. magnetron sputtering, 338
interface study of physically vapour-deposited TiN coatings on plasma-nitrided tool steel surfaces with Auger electron spectroscopy, resonant nuclear reaction analysis and Rutherford backscattering spectroscopy, 279
on the residual stress and picostructure of Ti nitride films I: Implantation with argon or krypton, 180

properties of TiN coatings deposited onto hot work steel substrates plasma nitrided at low pressure, 502
scuffing behavior of TiN-coated steel rollers under rolling and sliding conditions, 490
TiN films as microlaminate reinforcements in Al matrix composites, 77
tribological behavior of oil-lubricated TiN-coated steel, 496
X-ray elastic constants and residual stress of textured Ti nitride coating, 154
Tool steel
interface study of physically vapour-deposited TiN coatings on plasma-nitrided tool steel surfaces with Auger electron spectroscopy, resonant nuclear reaction analysis and Rutherford backscattering spectroscopy, 279
microstructure and tribological behaviour of plasma immersion ion implanted tool steels, 447
Tribology
a comparison of the tribological behaviour of several wear-resistant coatings, 459
microstructural and tribological study of triode magnetron sputtered V–C coatings: influence of partial pressure of reactive gas, 266
microstructure and tribological behaviour of plasma immersion ion implanted tool steels, 447
physical and tribological properties of rapid thermal annealed diamond-like C films, 576
properties of sputter-deposited hydrogenated C films as a tribological overcoat used in rigid magnetic disks, 552
some tribological observations of sliding W carbide coated steel against Al, 521
tribological behavior of oil-lubricated TiN-coated steel, 496
tribological properties of hard C films produced by the pulsed vacuum arc discharge method, 570
tribological properties of hard C films: extremely low friction mechanism of amorphous hydrogenated C films and amorphous hydrogenated SiC films in vacuum, 563
Tungsten
diamond film growth on cemented W carbides studied by scanning electron microscopy, Auger electron spectroscopy and X-ray photoelectron spectroscopy, 392
some tribological observations of sliding W carbide coated steel against Al, 521
structure and mechanical properties of hard W–C coatings deposited by reactive magnetron sputtering, 324
Tungsten carbide
reactor design for CVD of W carbide coatings, 198
Turbine components
compositionally graded thermal barrier coatings for high temperature aero gas turbine components, 58

Usage
new ways towards better exploitation of physical vapour deposition coatings, 470

Vacuum arc discharge
tribological properties of hard C films produced by the pulsed vacuum arc discharge method, 570
Vacuum plasma spraying
vacuum plasma sprayed alumina-titania coatings, 19
Vanadium
arc-evaporated Ti–V–N thin films, 249
preparation and characterization of V–N films deposited by reactive triode magnetron sputtering, 115

Wear
effect of process parameters on the residual stresses and the wear behavior of Al nitride physical vapor deposition coatings, 167
effects of surface composition, environment and morphology on friction and wear, 423
friction and wear of diamond and diamondlike carbon coatings, 428
performance and wear of carbide coated by physical vapour deposition in interrupted cutting, 453
rolling-contact fatigue and wear resistance of hard coatings on bearing-steel substrates, 482
study of the relative wear and abrasion resistance of Ti(C,N) and TiN coatings, 466
surface modification and wear characteristics of yttria-doped zirconia, 516
Wear resistance
a comparison of the tribological behaviour of several wear-resistant coatings, 459

X-ray elastic constants
X-ray elastic constants and residual stress of textured Ti nitride coating, 154

Yttria
surface modification and wear characteristics of yttria-doped zirconia, 516

Zirconia
effect of residual stress on martensitic transformation in plasma-sprayed ZrO_2 (8wt.% Y_2O_3) coatings, 64
surface modification and wear characteristics of yttria-doped zirconia, 516
thermomechanical behavior and phase relationships of plasma-sprayed zirconia coatings, 45
Zirconium
ion-beam deposition of Zr–Al multilayers and their structural properties, 335
morphology and mechanical properties of Al_2O_3, ZrO_2 and SiC laser-assisted physically vapour-deposited films, 541
sputter deposition of decorative coatings based on ZrB_2 and ZrB_{12}, 329